

Dan N Le

List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/9883206/publications.pdf>

Version: 2024-02-01

7
papers

26
citations

2258059

3
h-index

2053705

5
g-index

7
all docs

7
docs citations

7
times ranked

38
citing authors

#	ARTICLE	IF	CITATIONS
1	Highly Reliable Selection Behavior With Controlled Ag Doping of Nano-Polycrystalline ZnO Layer for 3D X-Point Framework. IEEE Electron Device Letters, 2022, 43, 21-24.	3.9	1
2	High wet-etch resistance SiO ₂ films deposited by plasma-enhanced atomic layer deposition with 1,1,1-tris(dimethylamino)disilane. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 2022, 40, 022406.	2.1	0
3	Relaxation Induced by Imprint Phenomena in Low-Temperature (400 Å°C) Processed Hf _{0.5} Zr _{0.5} O ₂ -Based Metal-Ferroelectric-Metal Capacitors. ACS Applied Electronic Materials, 2022, 4, 1405-1414.	4.3	2
4	Plasma-Enhanced Atomic-Layer Deposition of Nanometer-Thick SiN _x Films Using Trichlorodisilane for Etch-Resistant Coatings. ACS Applied Nano Materials, 2021, 4, 2558-2564.	5.0	8
5	A Novel Combinatorial Approach to the Ferroelectric Properties in Hf _x Zr _{1-x} O ₂ Deposited by Atomic Layer Deposition. Physica Status Solidi - Rapid Research Letters, 2021, 15, 2100053.	2.4	3
6	Nano-polycrystalline Ag-doped ZnO layer for steep-slope threshold switching selectors. AIP Advances, 2021, 11, 115213.	1.3	0
7	Low Temperature Thermal Atomic Layer Deposition of Aluminum Nitride Using Hydrazine as the Nitrogen Source. Materials, 2020, 13, 3387.	2.9	12